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Docket Number (Option NSC1-M1000	nal) Application	Number O
Applicant(s) John Jacob Stimson	III	112
Filing Date September 27, 2001	Group Art	Unit Vi de la Companya de la Company
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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	Name	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT					TRANS	LATION
	REF	NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	No
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OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

TOH	AA	John F. Mansfield et al.; "Development of a System to Provide Full, Real-time Remote Control of a Scanning Electron Microscope Across the Second Generation Internet: The Teaching SEM," Microscopy and Microanalysis, Vol. 6, pp. 31-41, 2000.
ToH	AB	Christopher Morgan et al.; "Toward a Standard for Remote Microscope Control Systems," Scanning, Vol. 20, pp. 110-116, 1998.

Examiner	Date Considered 7 Jae Jaco 4				
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